

501.35286C15

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: C. MIYAZAKI et al.
Serial No.: (new continuation application under
37 CFR 1.53[b] of application
Serial No. 09/771,670)
Filed: January 30, 2002
For: SEMICONDUCTOR DEVICE AND MANUFACTURING
METHOD THEREOF
Group: 2811
Examiner: THAI, L.



CLAIM FOR PRIORITY

Assistant Commissioner for Patents
Washington, D. C. 20231

January 30, 2002


Sir:

Pursuant to 35 U.S.C. §119 and 37 CFR §1.55, Applicants
hereby claim the right of priority based on the following
foreign application filed in Japan:

Application No. 08-066637, filed on March 22, 1996

A certified copy of this foreign application was filed
on June 27, 1997 in prior, original U. S. application Serial
No. 08/822,933, filed on March 21, 1997.

Respectfully submitted,
ANTONELLI, TERRY, STOUT & KRAUS, LLP


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